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Attorney Docket No. 02887.0270-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Tadashi MITSUI

Application No.: 10/807,187

Filed: March 24, 2004

For: PATTERN MEASURING  
APPARATUS, PATTERN  
MEASURING METHOD, AND  
MANUFACTURING METHOD OF  
SEMICONDUCTOR DEVICE

Group Art Unit: 2609

Examiner: David RASHID

Confirmation No.: 3737

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PETITION FOR EXTENSION OF TIME**

Applicant petitions for a one-month extension of time to file a reply to the Office  
Action dated March 26, 2007. The required fee of \$120.00 is enclosed.

Please grant any additional extensions of time required to enter the attached  
reply and charge any additional required fees to Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: July 26, 2007

By:

*Handwritten signature of Reece Nienstadt*

Reece Nienstadt  
Reg. No. 52,072

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